



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Masashi GOTO et al.

Title: **DIELECTRIC FILM, ITS FORMATION METHOD,
SEMICONDUCTOR DEVICE USING THE DIELECTRIC
FILM AND ITS PRODUCTION METHOD**

Application No.: 10/726,870

Filing Date: 2 December, 2003

Examiner/Unit: Dao H. Nguyen / 2818

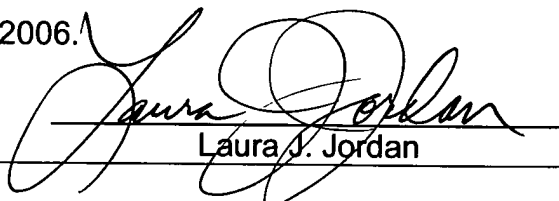
Attorney Docket No.: 2204-011-03

CERTIFICATE OF MAILING

I hereby certify that this communication, and any document being attached hereto,

☒ is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail addressed to: MS Amendments, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450

on this 30th day of January, 2006.



Laura J. Jordan

RESPONSE TO OFFICE ACTION DATED 29 SEPTEMBER 2005

TO COMMISSIONER FOR PATENTS

This communication is made in response to the above-referenced Office Action and it is requested that the examiner please amend and reconsider the application in view of this communication.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.